Total number of printed pages – 7 **BSCP 2202** 

## Fourth Semester Examination – 2008

## PHYSICS OF SEMICONDUCTOR DEVICES

Full Marks – 70

## Time: 3 Hours

Answer Question No. 1 which is compulsory and any five from the rest.

> The figures in the right-hand margin indicate marks.

Assume any data if not given in the question. You may use the physical constants given anywhere in the question paper.

- Answer the following questions : 1.  $2 \times 10$ 
  - Calculate the electron and hole concentra-(a) tion in a semiconductor in thermal equilibrium if intrinsic carrier concentration is  $1.5 \times 10^{10}$  cm<sup>-3</sup> and holes are 36  $\times 10^{4}$  times than the electrons per cm<sup>3</sup>.



- "Conduction in a p-type semiconductor is (b) due to holes in the conduction band." State whether the statement is true or false. Justify your answer.
- What is Einstein relation? Write down the (c) expression and define the terms.
- (d) Explain the process of excess carrier generation and recombination.
- Draw the energy band diagram of a reverse (e) biased p-n junction.
- Differentiate between Zener breakdown and (f) Avalanche breakdown.
- If two p-n junction diodes are connected, (q) such that both p sides are together, will the combined circuit behave as a transistor? Give reasons for your answer.
- Define Flat-Band voltage in a MOS. (h)
- Draw a CMOS invertor circuit. (i)
- (i) If  $\beta$  of a transistor is 50, calculate  $\alpha$  and  $\gamma$ .
- **BSCP 2202** 2 Contd.



B. Tech



- (a) Derive the expression to determine the position of the Fermi energy level as a function of the doping concentration and temperature.
  - (b) A semiconductor material made of silicon has an acceptor impurity concentration of  $N_a = 10^{16}$  per cm<sup>3</sup>. Calculate the concentration of donor impurity atoms that must be added so that the semiconductor is n-type and the Fermi energy is 0.13 eV below the conduction band edge.

Assume kT = 0.26 eV.

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- 3. (a) What is drift current ? Derive the expression for drift current density. 1+4
- (b) A semiconductor sample of Ga As at  $300^{\circ}$ K has doping concentration N<sub>a</sub> = 0 and N<sub>D</sub> =  $10^{16}$  per cm<sup>3</sup>. If the electron and hole mobilities are 8500 and 400 Cm<sup>2</sup> per BSCP 2202 3 P.T.O.

volt.sec respectively, calculate the drift current density under complete ionisation.

5

- 4. (a) Why is the general ambipolar transport equation nonlinear?
  - (b) A semiconductor has the following :

$$n_o = 10^{15} \text{ cm}^{-3}$$
  
 $n_i = 10^{10} \text{ cm}^{-3}$ 

Excess carrier lifetime is  $10^{-6}$  s.

Determine the electron-hole recombination rate if the excess-hole concentration is  $5 \times 10^{13}$  cm<sup>-3</sup>.

5. Calculate the built-in potential barrier in a (a) p-n junction given that 3 Semiconductor Silicon = 27°C Temperature  $1.5 \times 10^{18} \, \text{cm}^{-3}$ Na =  $1 \times 10^{15} \text{ cm}^{-3}$  $N_{d}$ = Thermal voltage 0.26 eV =  $1.5 \times 10^{10} \, \mathrm{cm}^{-3}$ n = **BSCP 2202** Contd. 4

- (b) Show that the total space charge width increases as a reverse bias voltage is applied.
  5
- (c) Determine the total width for Q5(a) if relative permittivity of the semiconductor is 11.7 and voltage applied is 5V. Assume permittivity in free space to be  $8.85 \times 10^{-14}$  F/cm.

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6. (a) Calculate the ideal reverse saturation current density in a silicon p-n junction of 300°K temperature, where, 3

$$N_a = N_d = 10^{16} \text{ cm}^-$$

$$n_i = 1.5 \times 10^{10} \text{ cm}$$

$$D_n = 25 \text{ cm}^2/\text{s}$$
  
 $D_n = 10 \text{ cm}^2/\text{s}$ 

$$\tau_{\rm no} = \tau_{\rm no} = 5 \times 10^{-7} \, {\rm s}$$

(b) Describe with illustrations how amplification takes place in a bipolar junction transister.

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- (c) Draw the bipolar transistor common-emitter
   V -I characteristics. Indicate saturation, cut
   off an active region. Mention significance
   of load line. 2
- 7. (a) Is MOS a voltage controlled or current controlled device ? Give reasons.
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  - (b) Draw the energy band diagrams of MOS capacity with p-type substrate when a negative gate bias and a moderate positive gate bias is applied. Repeat for n-type substrate when positive gate bias and a moderate negative gate bias is applied. 5
- (c) Calculate the oxide capacitance for MOS where thickness  $t_{ox} = 500$  Å and relative permittivity is 3.9. 2 BSCP 2202 6 Contd.

- 8. Write short notes on :  $2.5 \times 4$ 
  - **CMOS** technology (a)
  - Hybrid pi Model (b)
  - Frequency limitations in MOS (C)
  - Diffusion current. (d)

**BSCP 2202** 

7